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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Bong-Cheol Kim
Serial No. : 10/089,479 Examiner: To Be Assigned
Filed : March 28, 2002 Group Art Unit: 2812
For : APPARATUS AND METHOD FOR FORMING SINGLE
CRYSTALLINE NITRIDE SUBSTRATE USING HYDRIDE
VAPOR PHASE EPITAXY AND LASER BEAM

INFORMATION DISCLOSURE STATEMENT

I hereby certify that this paper is being deposited with the United States
Postal Service as first class mail in an envelope addressed to:
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September 3, 2002

Date of Deposit

James J. Maune

Attorney Name

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Signature

26,946

PTO Registration No.

September 3, 2002

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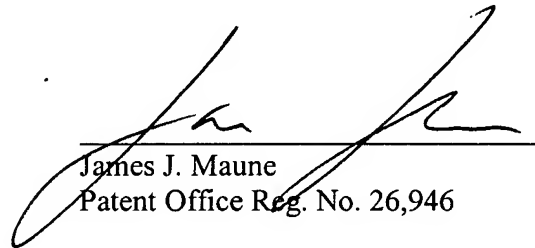
Commissioner for Patents
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Sir:

Pursuant to the provisions of 37 C.F.R. §§ 1.97 and 1.98, Applicant
respectfully requests that the references relating to the above-mentioned application listed
on attached PTO Form 1449, be made of record in the U.S. Patent and Trademark office.
Copies of the referenced citations are enclosed.

No fee is believed to be required in connection with this communication.
However, if a fee is required, the Commissioner is hereby authorized to charge the
payment of any fees to Deposit Account No. 02-4377.

Respectfully submitted,



James J. Maune
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Enclosures